



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
[www.uspto.gov](http://www.uspto.gov)

\*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 8409

SERIAL NUMBER 10/085,753	FILING DATE 02/28/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. TI-31620
-----------------------------	-----------------------------------	--------------	------------------------	------------------------------------

APPLICANTS

Toshihito Tsuga, Tsuchiura-shi, JAPAN;

Minoru Fube, Hayami-gun, JAPAN;  
Kazutaka Nakayama, Hayami-gun, JAPAN;

\*\* CONTINUING DATA ..... *MK (core)*

\*\* FOREIGN APPLICATIONS ..... *MK (verified)*

JAPAN 2001-059776 03/05/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/27/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 2
Verified and Acknowledged <i>mk</i>	Examiner's Signature <i>mk</i> Initials				

ADDRESS

23494  
TEXAS INSTRUMENTS INCORPORATED  
P O BOX 655474, M/S 3999  
DALLAS , TX  
75265

TITLE

Method and device for removing particles on semiconductor wafers

FILING FEE RECEIVED 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	---